

Attorney Docket No.: 042390.P6623

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Qing Ma, et al.

Application No: 09/374,502

Filed: August 13, 1999

For: ISOLATION STRUCTURE  
CONFIGURATIONS FOR MODIFYING  
STRESSES IN SEMICONDUCTOR DEVICES

Box Non-Fee Amendment  
Commissioner For Patents  
Washington, D.C. 20231

Examiner: J. Fenty

Art Unit: 2815

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AMENDMENT

Dear Sir:

In response to the Office Action mailed November 9, 2000, Applicants elect

Claim Set I, as set forth in the November 9, 2000 Office Action, which includes claims 1-

24. Please charge any shortages and credit any overcharges to our Deposit Account  
number 02-2666.

Respectfully submitted,  
BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN, LLP

Date: Nov. 28, 2000

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